5 September, 2016

High-robustness strain sensor based on in-fiber Fabry-Perot interferometer with an elliptical cavity Cailing Fu
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Dear High-robustness strain sensor based on in-fiber Fabry-Perot interferometer with an elliptical cavity Fu,

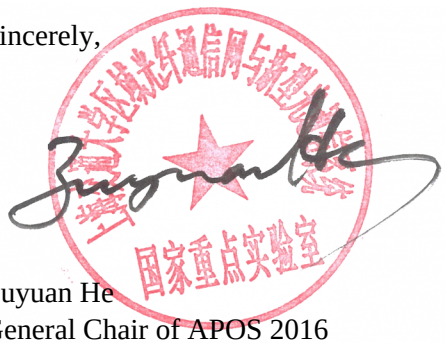
On behalf of the Program Committee of the **Asia-Pacific Optical Sensors Conference (APOS)**, I am sending you this letter to welcome your participation in the APOS 2016 conference, which is to be held 11-14 October 2016 in Shanghai, China at Shanghai Jiao Tong University. The meeting is open to all Optical Society of America (OSA), Society of Photographic Instrumentation Engineers (SPIE), IEEE Photonics Society, Chinese Optical Society (COS), Chinese Society for Optical Engineering(CSOE) members, and those with related optics interest.

Your participation in the meeting includes presenting your paper *High-robustness strain sensor based on in-fiber Fabry-Perot interferometer with an elliptical cavity(Control number:2553602)*, attending sessions in your area of interest, and an opportunity to communicate with others working in the field of optical sensors.

This is an invitation to participate in the meeting but not a personal sponsorship of your stay in China. You will need to secure your own funding for travel, registration, and housing expenses for the meeting.

Additional meeting information, including visa requirements, is available on the APOS website at www.apos2016.org. Thank you for your interest in the meeting and we look forward to seeing you in Shanghai.

Sincerely,



Zuyuan He
General Chair of APOS 2016
Professor, Shanghai Jiao Tong University